

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 89518  
LIN, Mou-Shiung, et al. : Confirmation Number: 6138  
Application No.: 09/523,990 : Group Art Unit: 2887  
Filed: March 13, 2000 : Examiner: WALSH, Daniel I.  
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For: METHOD OF MANUFACTURE AND IDENTIFICATION OF SEMICONDUCTOR  
CHIP MARKED FOR IDENTIFICATION WITH INTERNAL MARKING INDICIA  
AND PROTECTION THEREOF BY NON-BLACK LAYER AND DEVICE  
PRODUCED THEREBY

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE / AMENDMENT

Sir:

In response to the Office Action dated October 24, 2011 (hereinafter "Office Action"),  
entry and consideration of the following amendments and remarks are respectfully requested:

**Listing of the Claims** are reflected in the listing of claims which begins on page 2 of this  
paper.

**Remarks/Arguments** begin on page 5 of this paper.